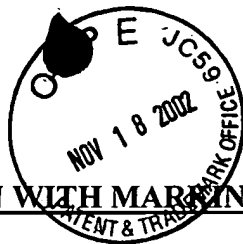


Application No. 10/058,708



**VERSION WITH MARKINGS TO SHOW CHANGES MADE**

**In the Specification:**

**PRIORITY APPLICATION**

*This patent application claims benefit under 35 U.S.C. 119(e) of the United States Provisional application number 60/340,554 filed on December 14, 2001, entitled: "SYSTEM FOR FORMING A SEMICONDUCTOR DEVICE AND METHOD THEREOF."*

**CO-PENDING APPLICATIONS**

This application is related to United States Patent Application Serial No. 10/058,852 entitled "SYSTEM FOR FORMING A SEMICONDUCTOR DEVICE AND METHOD THEREOF", filed on January 28, 2002, and having Attorney Docket Number 1458.TT4773; and United States Patent Application Serial No. 10/058,854 entitled "SYSTEM FOR FORMING A SEMICONDUCTOR DEVICE AND METHOD THEREOF" filed on January 28, 2002, and having Attorney Docket Number 1458.TT4962.

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